

# 8  
Hte. Acknowledgment  
D. Small-Logan  
4-302  
**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Attn: OFFICE OF PUBLICATIONS

Notice of Allowance

Mailed: August 19, 2002

Confirmation No.: 4482

Group Art Unit: 2851

Application No.: 09/697,639

Examiner: R. Fuller

Filed: October 27, 2000

Docket No.: 105193.01

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE USING  
THE EXPOSURE APPARATUS

**REQUEST FOR ACKNOWLEDGMENT OF  
CONSIDERATION OF DISCLOSED INFORMATION**

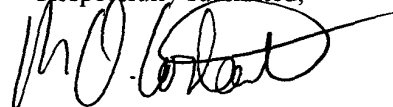
Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

An Information Disclosure Statement with Form PTO-1449 was filed in the above-captioned patent application on October 27, 2000. Applicant received back from the Examiner a partially initialed copy of the Form PTO-1449. The Examiner is respectfully requested to initial adjacent to JP-A-60-232552, and return to Applicant to acknowledge the fact that the Examiner has considered all of the cited disclosed information. For the convenience of the Examiner, a copy of that form is attached.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,



Mario A. Costantino  
Registration No. 33,565

MAC/ccs

Date: August 26, 2002

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